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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KANO et al.**

Group Art Unit: **2812**

Serial No.: **09/941,982**

Examiner: **Mulpuri, Savitri**

Filed: **August 30, 2001**

P.T.O. Confirmation No.: 7536

For. **METHOD OF FORMING NITRIDE-BASED SEMICONDUCTOR LAYER, AND
METHOD OF MANUFACTURING NITRIDE-BASED SEMICONDUCTOR
DEVICE**

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: May 5, 2004

Sir:

In response to the Office Action dated **November 5, 2003**, please amend the above-
identified application as follows: